

# Workshop of Optical Coatings in Precision Measurementの報告

Max-Planck Institute 山元 一広

2008/4/4 重力波研究交流会

# 会議の趣旨

Optical coating：精密光学実験の要

質の高い光学的性質

高反射率、低損失（吸収、散乱）、小さい形状誤差、などなど

小さい機械的散逸：熱雑音

重力波検出だけでなく周波数安定化、量子光学に波及

Optical coatingだけをkey wordにworkshop開催

# 会議の概要

場所：California Institute of Technology

日時：3/20（午後） - 21

LIGO-VIRGO joint meeting 3/17-20（午前）

日本人参加者（敬称略）：黒田、山本（博）、川村、山元（一）

Organizer：Gregg Harry (MIT)

詳細、スライド、参考文献は

<http://www.ligo.mit.edu/~gharry/workshop/workshop.html>

# Room201 (Bridge)



# セッション

Overview

Modeling and theory

Thermal noise

Scatter and optical loss

Absorption and thermal issues

Tours of Caltech labs

Overviewのみ20分 (+10分) 、他は15分 (+5分)

# *Overview*

Ion Beam Sputtering (Ramin Lalezani)

Gravitational Wave Detection (Steve Penn)

Quantum Optics (Markus Aspelmeyer)

micro mechanical oscillatorとcoatingについて

Laser Frequency Stabilization (Michael Martin)

# *Modeling and Theory*

Interferometer with insensitive to thermal noise

Optimization of coating layer thickness

Larger beam

Laser frequency stabilization

Scattering

# *Thermal noise*

Review (Gregg Harry)

Mechanical loss of silica/alumina coating

Mechanical loss at low temperature

Radiation pressure experiment (MIT)

Optimized coating in Thermal noise interferometer (Caltech)

Thermal noise interferometer with thin disk (Perugia)

Calculation of elasticity of  $Ta_2O_5$

Thermo-optic noise

Mesa beam experiment

Bench 7.0 (software to calculate interferometer sensitivity)

Absorption measurement



# *Scatter and optical loss*

## *Absorption and thermal issues*

Advanced LIGO目指して

Measurement of scatter, absorption, transmittance  
(doped coating)

Thermal compensation

Effect of ultraviolet ray irradiation

High power damage

# 低温における *coating mechanical loss*

Kazuhiro Yamamoto : Review

Iain Martin (Glasgow) :  $\text{SiO}_2$  and  $\text{Ta}_2\text{O}_5$

Eleanor Chalkley (Glasgow) :  $\text{HfO}_2$

## *2. Studies in Past*

### *2-1. Measurement of coating mechanical loss*

**3** experiments (in refereed journal)

(1) University of Tokyo

**K. Yamamoto et al., Physical Review D 74 (2006) 022002**

**First measurement**

(2) Friedrich-Schiller-University Jena

**R. Nawrodt et al., New Journal of Physics 9 (2007) 225**

**Coating on *grating***

(3) University of Glasgow

**I. Martin et al., Classical and Quantum Gravity 25 (2008) 055005**

**TiO<sub>2</sub> doping**

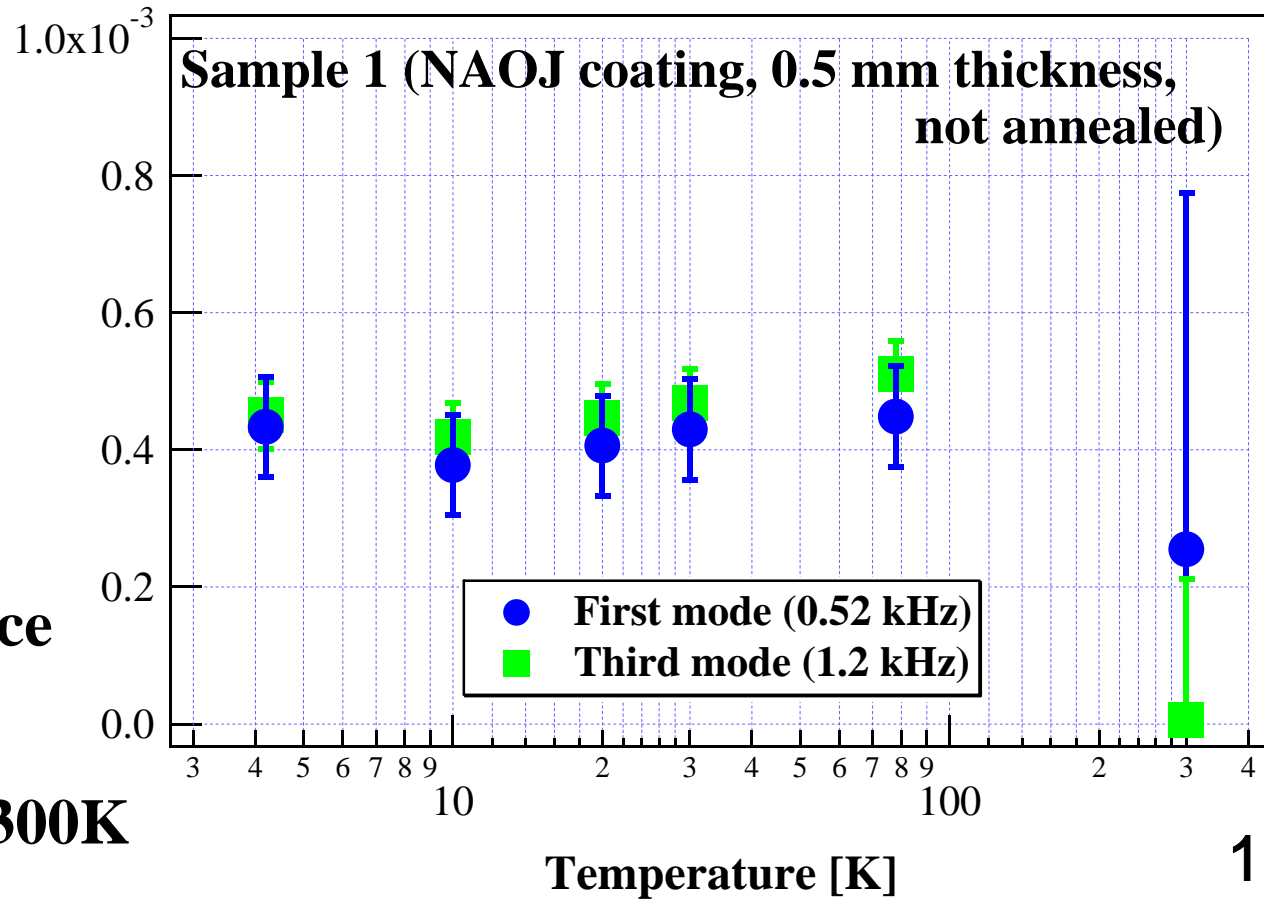
K. Yamamoto's slide

(1)University of Tokyo

K. Yamamoto's slide

K. Yamamoto et al., Physical Review D 74 (2006) 022002

**First measurement** SiO<sub>2</sub>/Ta<sub>2</sub>O<sub>5</sub> coating



**Weak**  
temperature  
dependence

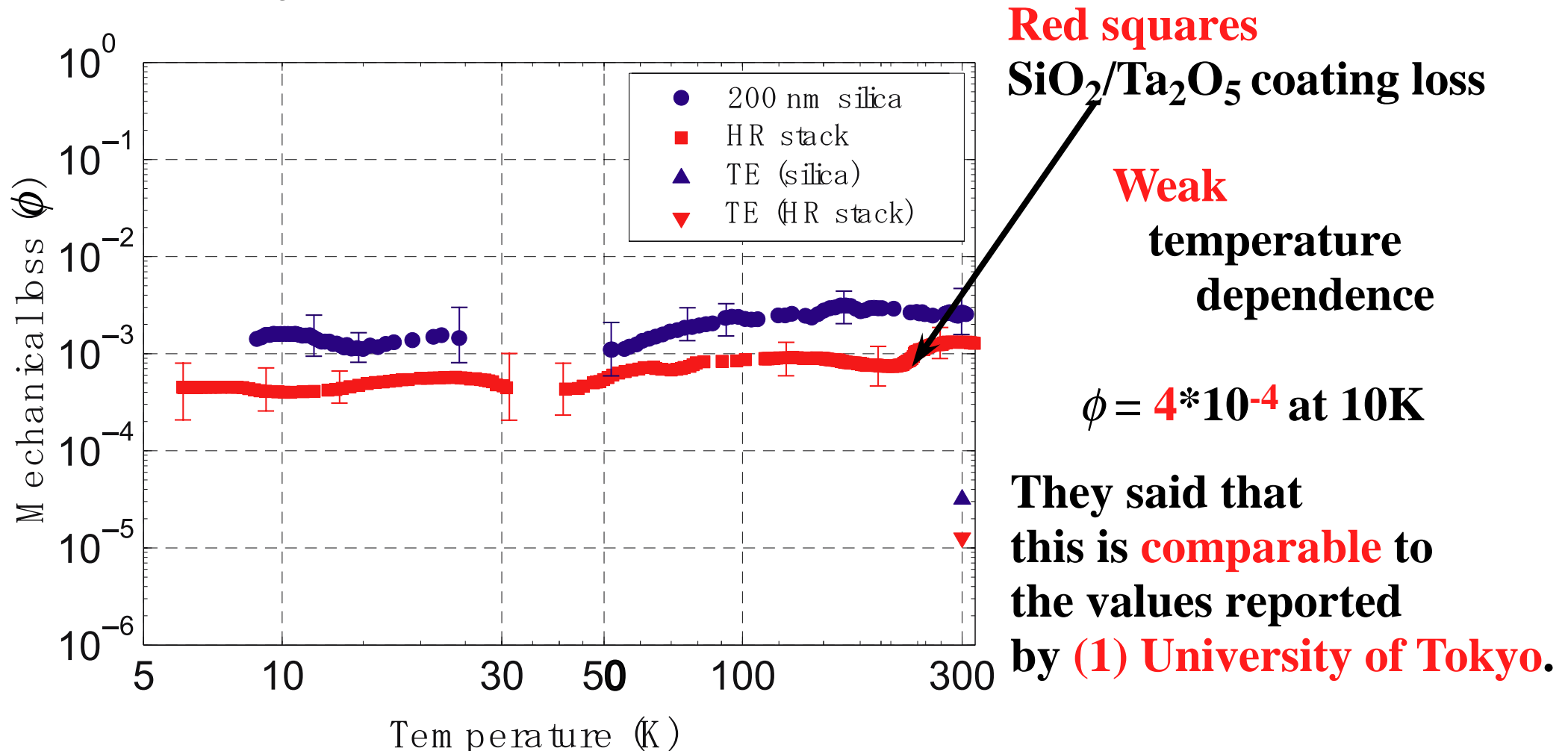
$$\phi = (4 - 6) * 10^{-4}$$

between 4K and 300K

## (2) Friedrich-Schiller-University Jena

R. Nawrodt et al., New Journal of Physics 9 (2007) 225

SiO<sub>2</sub>/Ta<sub>2</sub>O<sub>5</sub> coating on **grating**



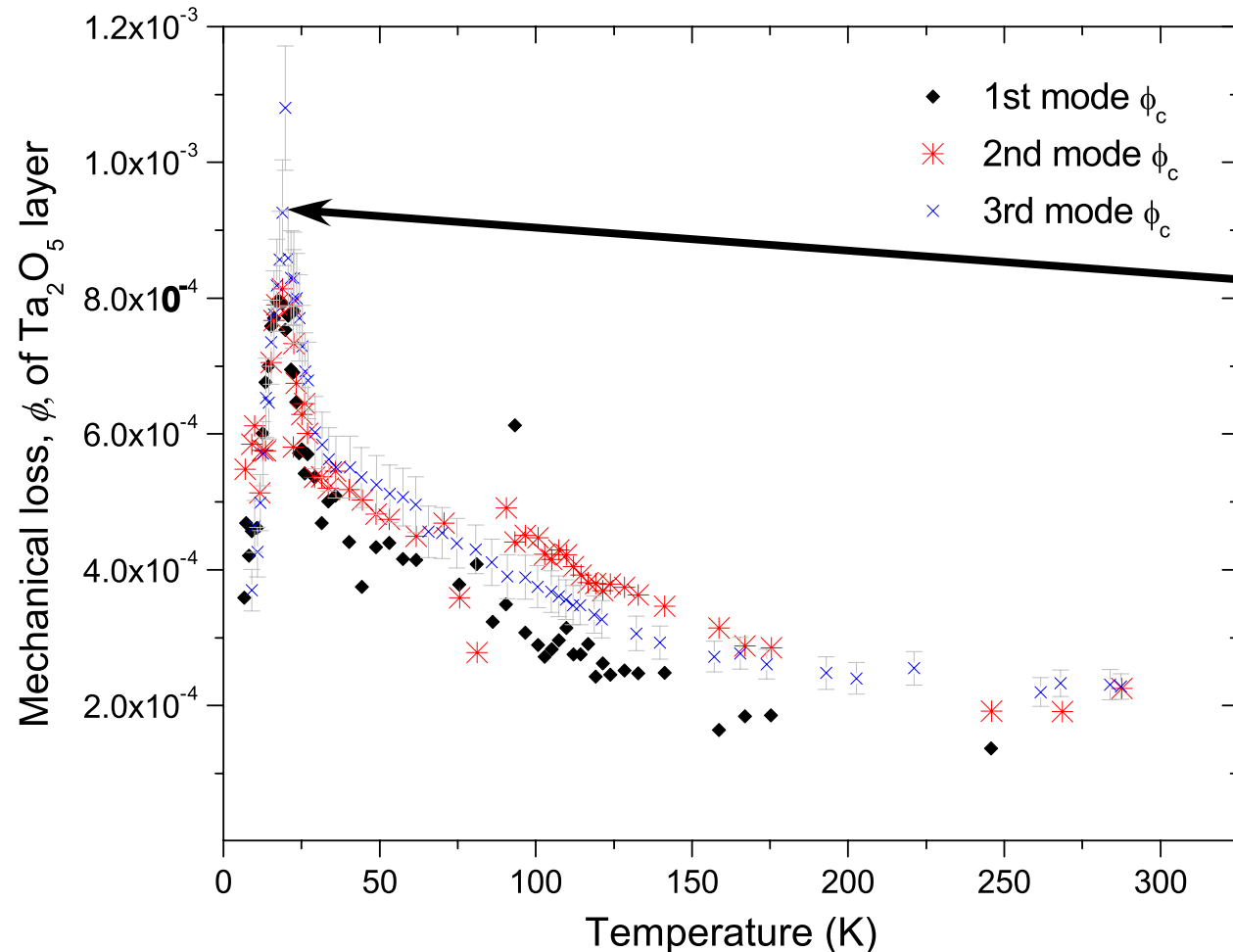
K. Yamamoto's slide

### (3) University of Glasgow

I. Martin et al., *Classical and Quantum Gravity* 25 (2008) 055005

**Ta<sub>2</sub>O<sub>5</sub> doped with TiO<sub>2</sub>**

(and his talk)



**Peak at 20 K**

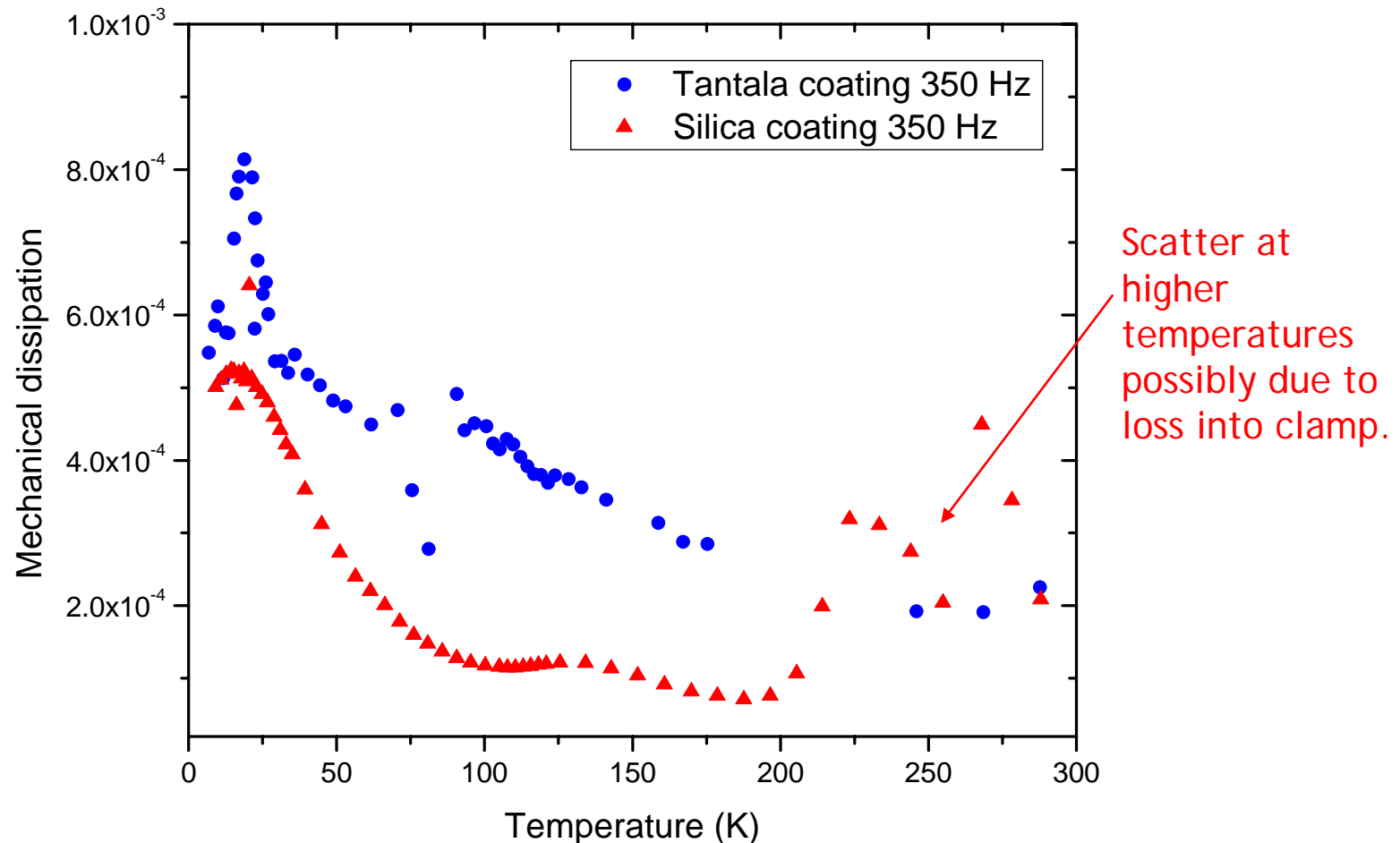
**This peak is comparable to the values reported by (1) University of Tokyo and (2) Friedrich-Schiller-University Jena.**

**smaller loss than that without doping except for 20K**

Figure 4. Temperature dependence of the loss of the doped Ta<sub>2</sub>O<sub>5</sub> coating.



# Comparison of $\text{SiO}_2$ and $\text{Ta}_2\text{O}_5$

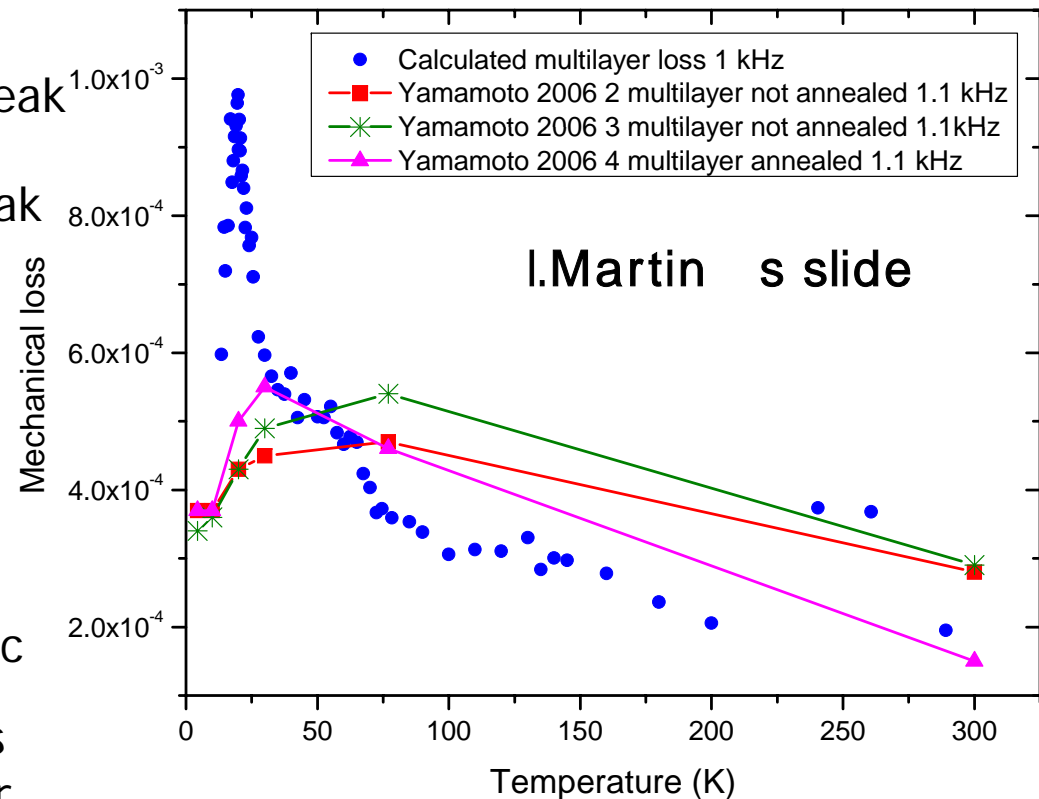


- Loss of ion beam sputtered  $\text{SiO}_2$  is significantly lower than loss of  $\text{Ta}_2\text{O}_5$  between 10 and 300 K.



## Comparison to multilayer results of Yamamoto et al

- Loss of single  $\text{SiO}_2$  and  $\text{Ta}_2\text{O}_5$  layers used to calculate loss in a 31 layer multilayer coating, as measured by Yamamoto et al\*
- Yamamoto's results:
  - Show no evidence of a large peak at 20 K
  - Are not inconsistent with a peak at slightly higher  $T$ , with  $T_{\text{peak}}$  possibly lowered by annealing
- Apparent discrepancy in results - could be explained by:
  - Differences in annealing temperature and / or coating layer thickness?
  - Different coating thermoelastic loss between coatings on sapphire and silicon substrates
  - Not enough data for multilayer coating



Calculated multilayer coating loss at 1 kHz  
compared to Yamamoto's measured multilayer  
loss at 1.1 kHz

\*Yamamoto et al., Phys. Rev. D 74, 022002 (2006)



# Plot showing coating loss for all modes studied

